



PATENT APPLICATION
RESPONSE UNDER 37 CFR § 1.115

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Rejda et al

Date: December 18, 2002

10/B
W.M.
1/9/03

Serial No: 09/930,741

Docket No.: STL 9825.00

Filed: August 15, 2001

Examiner: NA

For: ION MILL SHUTTER SYSTEM

Art Unit: NA

PRELIMINARY AMENDMENT UNDER 37 CFR 1.115

Commissioner of Patents and Trademarks
Washington, D.C. 20231

RECEIVED

DEC 23 2002

TC 1/00

Dear Sir:

Preliminary to examination please amend the above identified application as follows:

Amendments

Please amend claims 1, 3, 4, 6, 8, 9, 17, 18, 19 and add claims 21-39.

1. (Amended) A method for producing magneto resistive heads comprising the steps of:

positioning at least two magneto resistive elements in spaced relation to one another;

placing the at least two magneto resistive elements in an environment where material is removed [nonselectively] from items in the environment;

monitoring a property of the at least two [of the plurality of] magneto resistive elements; and

31
01/09/2003 WITCHEL 00000006 500372 09930741
CH 00 CH
252-00 CH
342-00 CH
01 FC:1201
02 FC:1202